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Tsu shih Kun-Ku Hung Wen-Hun Tung Wen-Chih Chiou	05/0,	7/02	/	No. 121 Park Science-Bas		ark Co.4.1711
3 Nature of conveyance: Assignment	☐ Merger			Additional name(s	s) & address(es) atta	r ■
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Other: Execution Date: Jan. 3	0, 2002					
4 Application number(s) or p	patent number(s)	:		W-4	***************************************	- Physical Lea
If this document is being fi	iled together with	a new application,	the	execution date of	f the application is	::01-30-02
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5 Name and address of part concerning document sho	ty to whom corres	tional numbers atta	ched		f applications and 1	patents involved:
RANDY W. TUNG Tung & Associates			7	Total fee (37 CF	FR 3.41)	\$40.00
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Randy W. Tung Name of Person Signing		Signature				
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Washington, D.C. 20231

ASSIGNMENT

WHEREAS, we, <u>TSU SHIH, KUN KU HUNG</u>, <u>WEN-HUN TUNG</u> and <u>WEN-CHIM</u>

CHIOU, have invented certain improvements in

METHOD FOR PREVENTING OR REDUCING

ANODIC CU CORROSION DURING CMP

for which we are about to make application for Letters Patent of the United States; and

WHEREAS, TAIWAN SEMICONDUCTOR MANUFACTURING CO., LTD. of No. 121, Park Avenue 3, Science-Based Industrial Park, Hsin-Chu, Taiwan, R.O.C, is desirous of acquiring the entire right, title and interest in and to said invention;

1

PATENT REEL: 012886 FRAME: 0478 divisional, continuation or continuation-in-part application thereof, and in and to any reissue of any such patent, and in and to any patent applications which may be filed on said invention in countries foreign to the United States and any Letters Patent granted thereon.

We further authorize said corporation to apply for foreign patents on said invention in its own name or through its designees, including subsidiaries, related companies or assignees, under the International Convention or otherwise, and we further agree to execute all papers, including those required for the United States and foreign applications, and to perform such other proper acts as said corporation or its designees the rights herein assigned.

Jon Shik TSU SHIH

Wen Hun Tung WEN-HUN TUNG

KUN KU HUNG

Wen Chih Chiou

WEN-CHIX CHIOU

TUNG & ASSOCIATES 838 W. Long Lake Road Suite 120 Bloomfield Hills, Michigan 48302

RECORDED: 05/07/2002